

## Annex 4: Test setup photographs 21-1-0116002T01a-A4

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<b>Testing company:</b>	CETECOM GmbH Im Teelbruch 116 45219 Essen Germany Tel. + 49 (0) 20 54 / 95 19-0 Fax: + 49 (0) 20 54 / 95 19-150	<b>Applicant:</b>	ALOIS KOBER GMBH
<b>Product:</b>	E&P levelsystem		
<b>Model:</b>	E&P levelsystem Touchpanel		
<b>FCC ID:</b>	2A5AD-4100938	<b>IC:</b>	N/A
<b>Testing has been carried out in accordance with:</b>	Title 47 CFR, Chapter I FCC Regulations, Subchapter A Part 15, Subpart C: §15.249  Deviations, modifications or clarifications (if any) to above mentioned documents are written in each section under "Test method and limit".		

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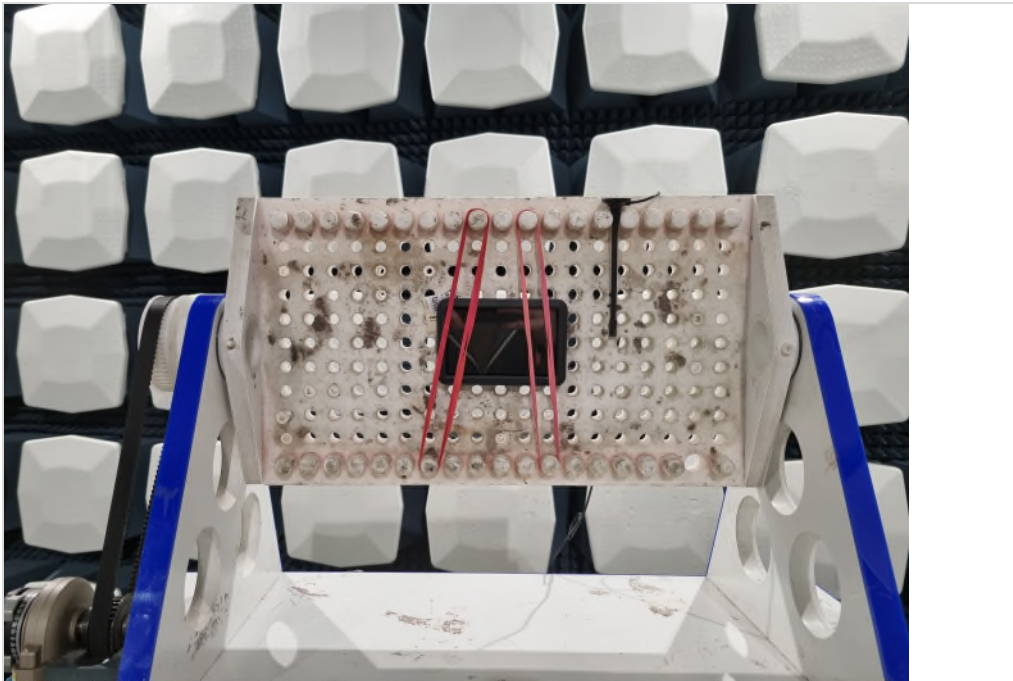
## 1 Test setup photographs



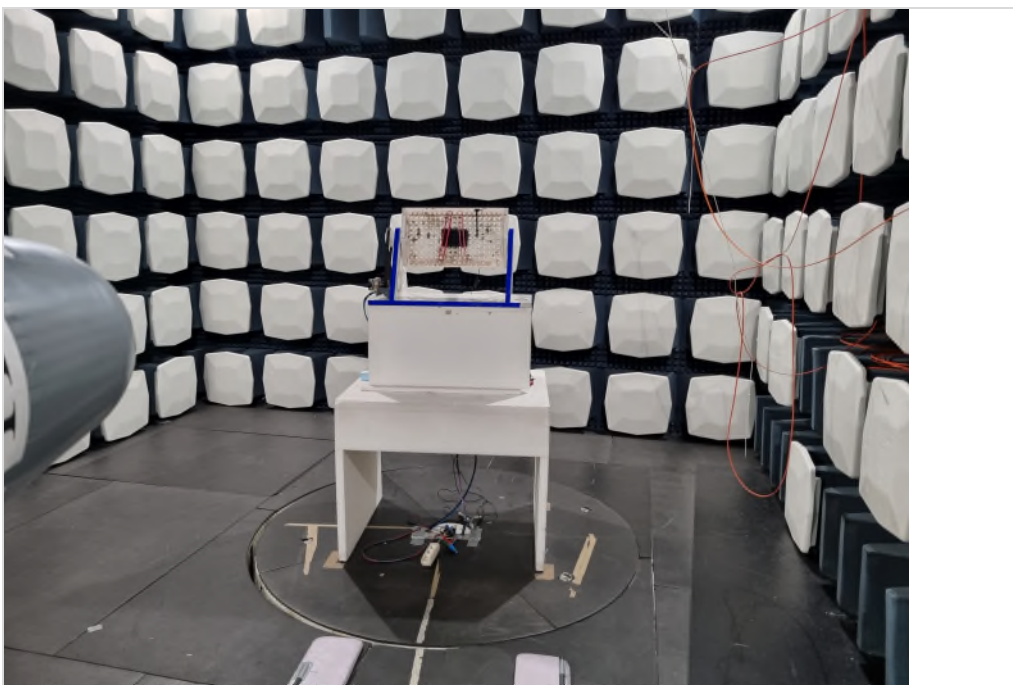
Photograph 1: EUT test setup in the fully anechoic chamber, close up view\_EUT elevation 0°



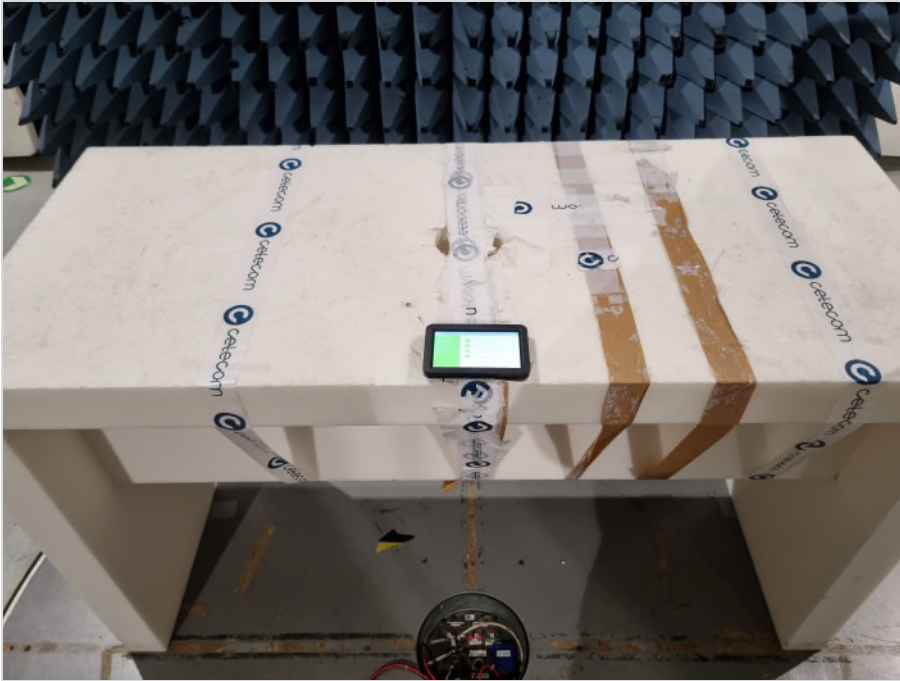
Photograph 2: EUT test setup in the fully anechoic chamber, overview\_EUT elevation 0°



Photograph 3: EUT test setup in the fully anechoic chamber, close up view\_EUT elevation 90°



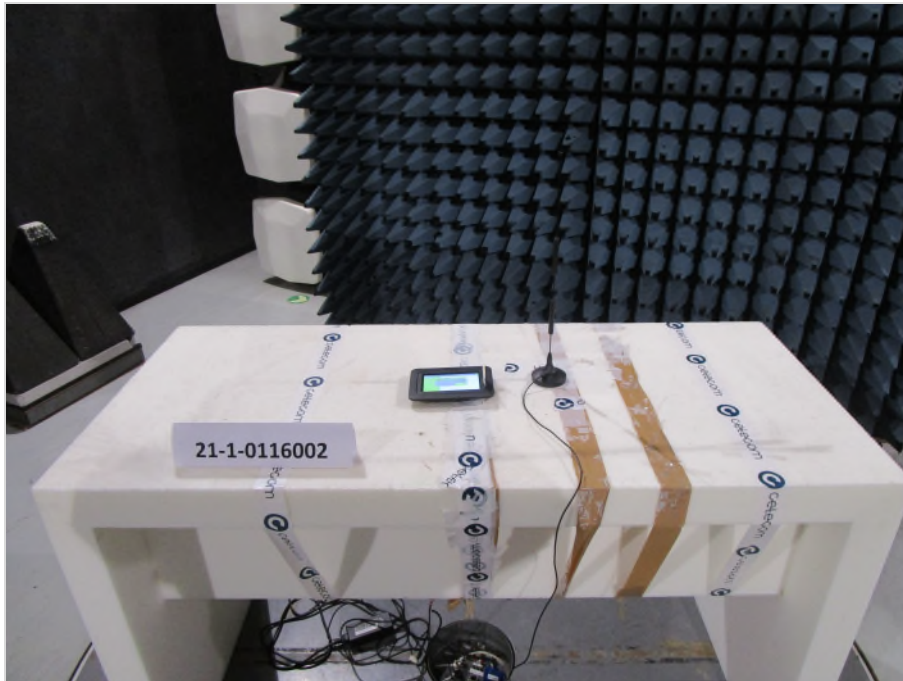
Photograph 4: EUT test setup in the fully anechoic chamber, overview\_EUT elevation 90°



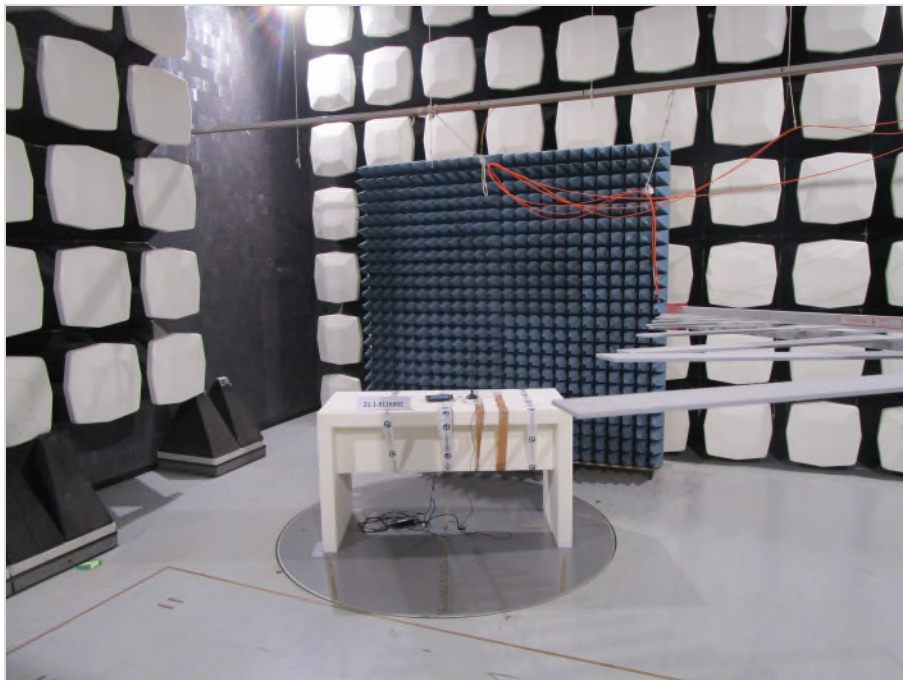
Photograph 5: EUT test setup in the semi anechoic chamber with floor absorber for H-Field measurement, close up view\_EUT elevation 0°



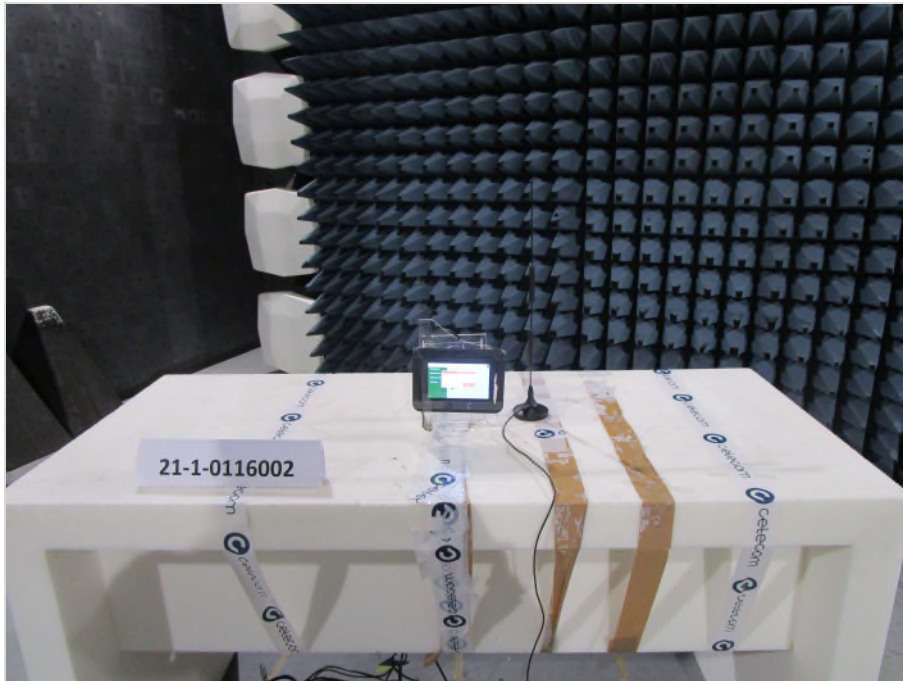
Photograph 6: EUT test setup in the semi anechoic chamber with floor absorber for H-Field measurement, overview\_EUT elevation 0°



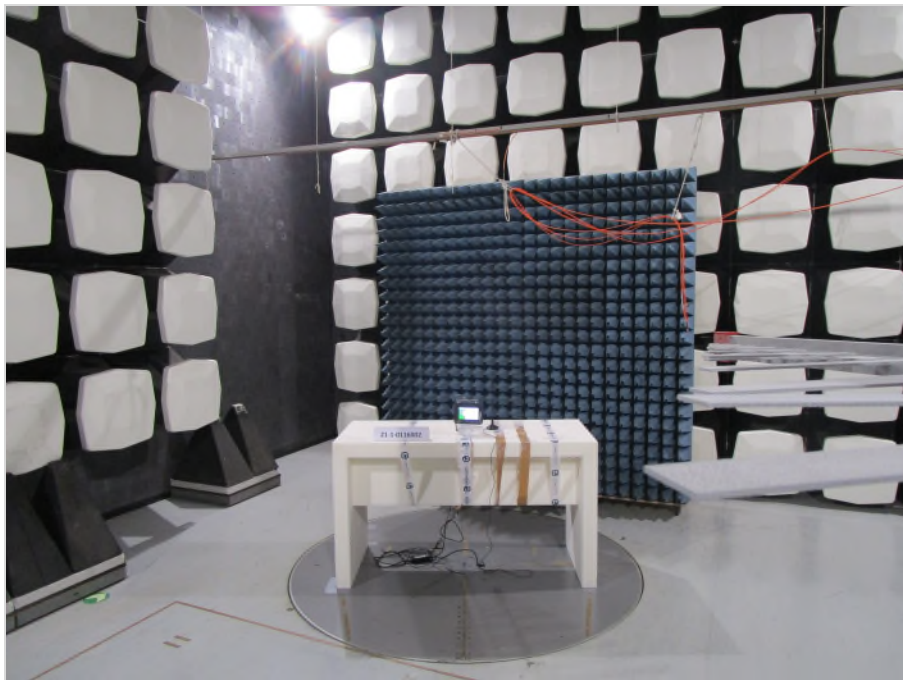
Photograph 7: EUT test setup in the semi anechoic chamber without floor absorber for E-Field measurement, close up view\_EUT elevation 0°



Photograph 8: EUT test setup in the semi anechoic chamber without floor absorber for E-Field measurement, overview\_EUT elevation 0°



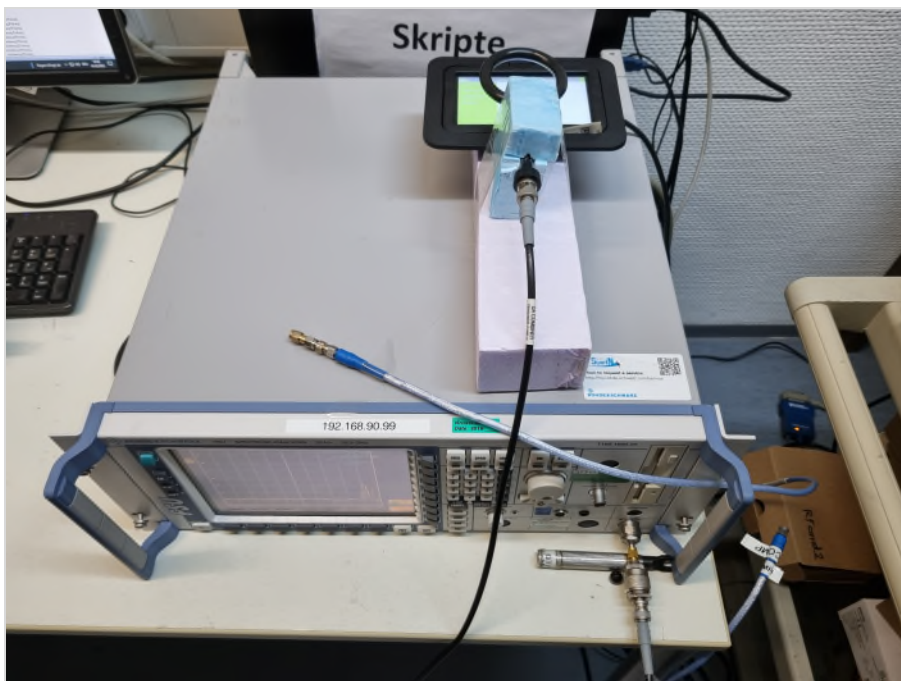
Photograph 9: EUT test setup in the semi anechoic chamber without floor absorber for E-Field measurement, close up view\_EUT elevation 90°



Photograph 10: EUT test setup in the semi anechoic chamber without floor absorber for E-Field measurement, overview\_EUT elevation 90°



Photograph 11: EUT setup conducted measurement with near field probe, close up view



Photograph 12: EUT setup conducted measurement with near field probe, overview

**End Of Annex 4**